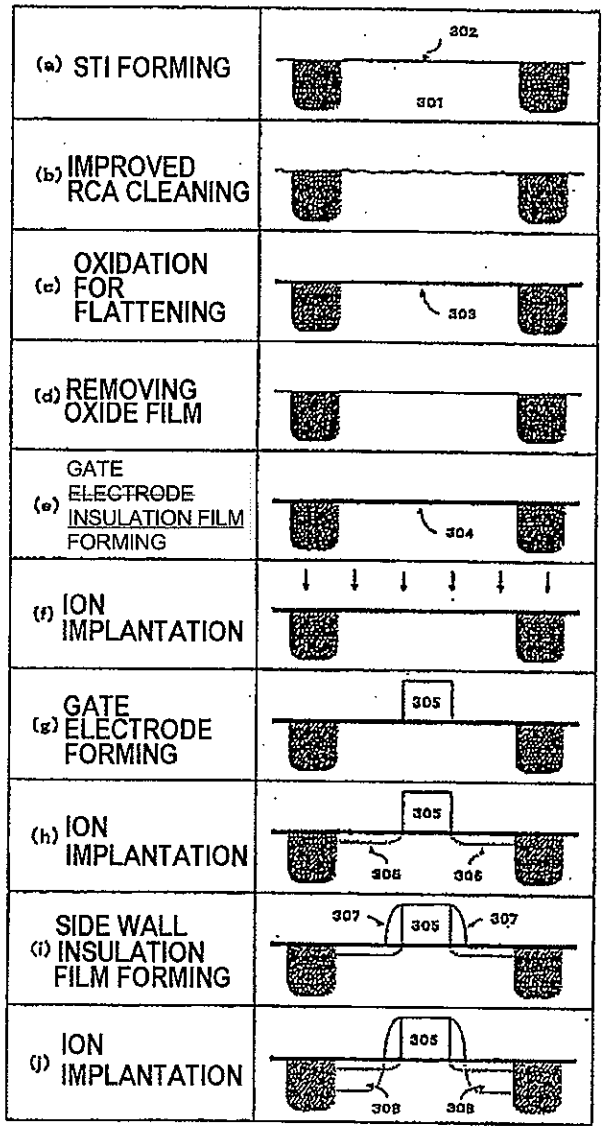

(a) STI FORMING
302
301
(b) IMPROVED RCA CLEANING
(c) OXIDATION FOR FLATTENING
303
(d) REMOVING OXIDE FILM
(e) GATE ELECTRODE INSULATION FILM FORMING
304
(f) ION IMPLANTATION
(g) GATE ELECTRODE FORMING
305
(h) ION IMPLANTATION
306
306
(i) SIDE WALL INSULATION FILM FORMING
307
305
307
(j) ION IMPLANTATION
305
308
308

FIG. 3